

**INFORMATION DISCLOSURE STATEMENT**

Case Name. M.S. Hodes 3-10-15-19-13-6
Serial No. 10/674448
Applicant: M.S. Hodes, et al.
Filing Date: September 30, 2003
Group:

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Dat
/JN/	AA	10/403159		Komblit, A.			3/31/2003
/JN/	AB	10/649285		Komblit, A.			8/27/2003

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

/JN/	AC	Kim, J., Kim, C-J., Nanostructured Surfaces For Dramatic Reduction Of Flow Resistance In Droplet-Based Microfluidics, IEEE 2002, pages 479-482

***References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

***Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

EXAMINER /Jyoti Nagpaul/	DATE CONSIDERED 04/24/2007
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/JN/	AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
	AB	US Pat. App. 10/798084		Arney, et al			3/11/2004
	AC	US Pat. App. 10/806543		Arney, et al			3/23/2004
	AD	US Pat. App. 10/816569		Gasparyan, et al.			4/1/2004
	AE	US Pat. App. 10/674448		Hodes, et al.			9/30/2003
	AF	US Pat. App. 10/803565		Hodes, et al.			3/18/2004
	AG	US Pat. App. 10/803641		Hodes, et al.			3/18/2004
	AH	US Pat. App. 10/403159		Kornblit, et al.			3/31/2003
	AI	US Pat. App. 10/649285		Kornblit, et al.			8/27/2003
	AJ	US Pat. App. 10/716084		Kroupenkine, et al.			11/18/2003
↓	AK	US Pat. App. 10/803576		Kroupenkine, et al.			3/18/2004
/JN/	AL	US Pat. App. 10/810774		Kroupenkine, et al.			3/26/2004

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/JN/	AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002).

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